## PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  $\frac{1}{3}$ 

In re the Application of

Eiji NATORI

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Application No.: 09/819,688

Filed: March 29, 2001

METHOD AND DEVICE FOR MANUFACTURING CERAMICS, For:

SEMICONDUCTOR DEVICE AND PIEZOELECTRIC DEVICE

Group Art Unit: 2 Examiner:

Docket No.:

109120 CENTER 2800

## STATEMENT OF SUBSTANCE OF INTERVIEW UNDER MPEP §713.04

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

A personal interview was held with Examiner Hogans on April 16, 2003 in connection with the above-identified Application. Applicant thanks the Examiner for the courtesies extended to Applicant's representatives during the interview.

During the interview, the distinguishing features of the invention with respect to the references applied in the December 30, 2003 Office Action were discussed. The points presented paralleled those found in the Request for Reconsideration filed March 31, 2003, especially that none of the applied references disclosed the active species as recited in the

pending claims 1-13 and 15-17. The Examiner stated the points will be fully and fairly considered.

Respectfully submitted,

James A. Oliff

Registration No. 27,075

J. Adam Neff

Registration No. 41,218

JAO:JAN/SSK/kap

Date: May 14, 2003

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE AUTHORIZATION

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